

CPC**COOPERATIVE PATENT CLASSIFICATION****H05H**

PLASMA TECHNIQUE (fusion reactors G21B; ion-beam tubes [H01J 27/00](#); magnetohydrodynamic generators [H02K 44/08](#); producing X-rays involving plasma generation [H05G 2/00](#)); **PRODUCTION OF ACCELERATED ELECTRICALLY-CHARGED PARTICLES OR OF NEUTRONS** (obtaining neutrons from radioactive sources G21, e.g. G21B, G21C, G21G); **PRODUCTION OR ACCELERATION OF NEUTRAL MOLECULAR OR ATOMIC BEAMS** (atomic clocks [G04F 5/14](#); devices using stimulated emission H01S; frequency regulation by comparison with a reference frequency determined by energy levels of molecules, atoms, or subatomic particles [H03L 7/26](#))

H05H 1/00**Generating plasma; Handling plasma**

- H05H 1/0006 . {Investigating plasma, e.g. degree of ionisation (electron temperature)}
- H05H 1/0012 .. {by using radiation}
- H05H 1/0018 ... {Details}
- H05H 1/0025 ... {by using photoelectric means ([H05H 1/0031](#) to [H05H 1/0043](#) take precedence)}
- H05H 1/0031 ... {by interferometry}
- H05H 1/0037 ... {by spectrometry (see [G01N 3/00](#))}
- H05H 1/0043 ... {by using infra-red or ultra-violet radiation}
- H05H 1/005 ... {by using X-rays or alpha rays (see [G01N 23/00](#))}
- H05H 1/0056 ... {by using neutrons (see [G01N 23/00](#))}
- H05H 1/0062 ... {by using microwaves (see **G01N 23/34**)}
- H05H 1/0068 .. {by thermal means (see [G01N 25/00](#))}
- H05H 1/0075 ... {Langmuir probes}
- H05H 1/0081 .. {by electric means (see [G01N 27/00](#), [G01R](#))}
- H05H 1/0087 .. {by magnetic means (see [G01N 27/00](#), [G01R](#))}
- H05H 1/0093 .. {by acoustic, e.g. ultrasonic means (see [G01N 29/02](#))}

- H05H 1/02 . Arrangements for confining plasma by electric or magnetic fields; Arrangements for heating plasma ({[G21B 1/00](#) takes precedence;} electron optics H01J)
- H05H 1/03 .. using electrostatic fields
- H05H 1/04 .. using magnetic fields substantially generated by the discharge in the plasma
- H05H 1/06 ... longitudinal pinch devices
- H05H 1/08 ... Theta pinch devices {e.g. SCYLLA}
- H05H 1/10 .. using externally-applied magnetic field only {e.g. Q-machines, Yin-Yang, base-ball}
- H05H 1/105 ... {using magnetic pumping}
- H05H 1/11 ... using cusp configuration ([H05H 1/14](#) takes precedence)
- H05H 1/12 ... wherein the containment vessel forms a closed or nearly closed loop ({[G21B 1/05](#) takes precedence)}
- H05H 1/14 ... wherein the containment vessel is straight and has magnetic mirrors {electron

- mirrors **G21K 1/08B**
- H05H 1/16 .. using externally-applied electric and magnetic field
- H05H 1/18 ... wherein the field oscillate at very high frequency, e.g. in the microwave range {e.g. using cyclotron resonance}
- H05H 1/20 .. Ohmic heating
- H05H 1/22 .. for injection heating {(G21B 1/15 takes precedence)}
- H05H 1/24 . Generating plasma {(gas-filled discharge reactors H01J 37/32; nuclear fusion reactors G21B 1/00; ohmic heating H05H 1/20; injection heating H05H 1/22)}
- H05H 1/2406 .. { Dielectric barrier discharges}
- H05H 1/2475 .. { Acoustic pressure discharge}
- H05H 1/26 .. Plasma torches {(metal working with constricted arc B23K 10/00, H05H 10/02; metal spraying B05B 7/18, B05B 7/20)}
- H05H 1/28 ... Cooling arrangements
- H05H 1/30 ... using applied electromagnetic fields, e.g. high frequency or microwave energy (H05H 1/28 takes precedence)
- H05H 1/32 ... using an arc (H05H 1/28 takes precedence)
- H05H 1/34 Details, e.g. electrodes, nozzles {cf. B23K 9/24}
- H05H 1/3405 {Arc stabilising or constricting arrangements, e.g. by an additional gas flow (by externally applied magnetic field H05H 1/40; by using powders or liquids H05H 1/42; using coaxial protecting fluid H05H 1/341)}
- H05H 1/341 {using coaxial protecting fluid (arc stabilising or constricting arrangements H05H 1/3405; introducing materials into the plasma H05H 1/42)}
- H05H 1/36 Circuit arrangements (H05H 1/38, H05H 1/40 take precedence)
- H05H 1/38 Guiding or centering of electrodes
- H05H 1/40 using applied magnetic fields, e.g. for focusing or rotating the arc {cf. B23K 9/08, B23K 9/06C5}
- H05H 1/42 with provision for introducing materials into the plasma, e.g. powder, liquid (electrostatic spraying, spraying apparatus with means for charging the spray electrically B05B 5/00){cf. B23K 9/324, B05B 7/22; arc stabilising or constricting arrangements H05H 1/3405; coaxial protecting fluids H05H 1/341}
- H05H 1/44 using more than one torch
- H05H 1/46 .. using applied electromagnetic fields, e.g. high frequency or microwave energy (H05H 1/26 takes precedence)
- H05H 1/48 .. using an arc (H05H 1/26 takes precedence)
- H05H 1/50 ... and using applied magnetic fields, e.g. for focusing or rotating the arc
- H05H 1/52 .. using exploding wires or spark gaps (H05H 1/26 takes precedence; spark gaps in general H01T)
- H05H 1/54 . Plasma accelerators
- H05H 3/00** **Production or acceleration of neutral particle beams, e.g. molecular or atomic beams**
- H05H 3/02 . Molecular or atomic beam generation {(charge exchange devices G21K 1/14; polarising devices G21K 1/16; using resonance or molecular beams for analysing or

investigating materials [G01N 24/002](#); atomic clock [G04F 5/14](#); beam masers [H01S 1/06](#));

- H05H 3/04 . Acceleration by electromagnetic wave pressure
- H05H 3/06 . Generating neutron beams (targets for producing nuclear reactions [H05H 6/00](#); neutron sources [G21G 4/02](#))
- H05H 5/00** **Direct voltage accelerators; Accelerators using single pulses** ([H05H 3/06](#) takes precedence)
- H05H 5/02 . Details (targets for producing nuclear reactions [H05H 6/00](#))
- H05H 5/03 . . Accelerating tubes (vessels or containers of electric discharge tubes with improved potential distribution over surface of vessel [H01J 5/06](#); shields of X-ray tubes associated with vessels or containers [H01J 35/16](#))
- H05H 5/04 . { energised by electrostatic generators}
- H05H 5/042 . . { of the van de Graaf type}
- H05H 5/045 . . { High voltage cascades, e.g. Greinacher cascade}
- H05H 5/047 . . { Pulsed generators}
- H05H 5/06 . { Multistage accelerators}
- H05H 5/063 . . { Tandems}
- H05H 5/066 . . { Onion-like structures}
- H05H 5/08 . Particle accelerators using step-up transformers, e.g. resonance transformers
- H05H 6/00** **Targets for producing nuclear reactions** (supports for targets or objects to be irradiated [G21K 5/08](#)){preparation of tritium [C01B 4/00](#)}; {targets, e.g. pellets for fusion reactions by laser or charged particles beam injection [H05H 1/22](#)}
- H05H 6/005 . {Polarised targets (polarising devices, e.g. for obtaining a polarised ion beam [G21K 1/16](#))}
- H05H 7/00** **Details of devices of the types covered by groups [H05H 9/00](#), [H05H 11/00](#), [H05H 13/00](#)**
- H05H 7/001 . { Arrangements for beam delivery or irradiation (irradiation systems per se [G21K 5/00](#))}
- H05H 7/02 . Circuits or systems for supplying or feeding radio-frequency energy (radio-frequency generators [H03B](#))
- H05H 7/04 . Magnet systems {e.g. undulators, wigglers (free-electron laser [H01S 3/0903](#))}; Energisation thereof
- H05H 7/06 . Two-beam arrangements; Multi-beam arrangements {storage rings}; Electron rings
- H05H 7/08 . Arrangements for injecting particles into orbits

- H05H 7/10 . Arrangements for ejecting particles from orbits
- H05H 7/12 . Arrangements for varying final energy of beam
- H05H 7/14 . Vacuum chambers ([H05H 5/03](#) takes precedence)
- H05H 7/16 . . . of the waveguide type
- H05H 7/18 . . . Cavities; Resonators {(travelling-wave tubes [H01J 23/18](#); hyperfrequency cavities in general [H01P 7/04](#), [H01P 7/06](#))}
- H05H 7/20 . . . with superconductive walls
- H05H 7/22 . Details of linear accelerators, e.g. drift tubes ([H05H 7/02](#) to [H05H 7/20](#) take precedence)

- H05H 9/00 Linear accelerators**
- H05H 9/005 . { Dielectric wall accelerators}
- H05H 9/02 . Travelling-wave linear accelerators {travelling-wave tubes [H01J 25/34](#)}
- H05H 9/04 . Standing-wave linear accelerators
- H05H 9/041 . . . { Hadron LINACS}
- H05H 9/042 . . . { Drift tube LINACS}
- H05H 9/044 . . . { Coupling cavity LINACS, e.g. side coupled}
- H05H 9/045 . . . { Radio frequency quadrupoles}
- H05H 9/047 . . . { Hybrid systems}
- H05H 9/048 . . . { Lepton LINACS}

- H05H 11/00 Magnetic induction accelerators, e.g. betatrons**
- H05H 11/02 . Air-cored betatrons
- H05H 11/04 . Biased betatrons

- H05H 13/00 Magnetic resonance accelerators; Cyclotrons {(strophotrons, turbine tubes [H01J 25/62](#))}**
- H05H 13/005 . { Cyclotrons}
- H05H 13/02 . Synchrocyclotrons, i.e. frequency modulated cyclotrons
- H05H 13/04 . Synchrotrons
- H05H 13/06 . Air-cored magnetic resonance accelerators
- H05H 13/08 . Alternating-gradient magnetic resonance accelerators
- H05H 13/085 . . . { Fixed-field alternating gradient accelerators [FFAG]}

- H05H 13/10 . Accelerators comprising one or more linear accelerating sections and bending magnets or the like to return the charged particles in a trajectory parallel to the first accelerating section, e.g. microtrons

- H05H 15/00 **Methods or devices for acceleration of charged particles not otherwise provided for****

- H05H 2001/00 **Generating plasma; Handling plasma****

- H05H 2001/24 . Generating plasma {(gas-filled discharge reactors [H01J 37/32](#); nuclear fusion reactors [G21B 1/00](#); ohmic heating [H05H 1/20](#); injection heating [H05H 1/22](#)}
- H05H 2001/2406 .. { Dielectric barrier discharges}
 - H05H 2001/2412 ... the dielectric being interposed between the electrodes
 - H05H 2001/2418 ... the electrodes being embedded in the dielectric
 - H05H 2001/2425 ... the electrodes being flush with the dielectric
 - H05H 2001/2431 ... Cylindrical electrodes
 - H05H 2001/2437 ... Multilayer systems
 - H05H 2001/2443 ... Flow through, i.e. the plasma fluid flowing in a dielectric tube
 - H05H 2001/245
 - H05H 2001/2456
 - H05H 2001/2462
 - H05H 2001/2468
- H05H 2001/2475 .. { Acoustic pressure discharge}
 - H05H 2001/2481 ... Piezoelectric actuators
 - H05H 2001/2487 ... Mechanical actuators
 - H05H 2001/2493 ... Horns
- H05H 2001/26 .. Plasma torches {(metal working with constricted arc [B23K 10/00](#), [H05H 10/02](#); metal spraying [B05B 7/18](#), [B05B 7/20](#))}
 - H05H 2001/32 ... using an arc ([H05H 1/28](#) takes precedence)
 - H05H 2001/34
 - H05H 2001/3415 indexing scheme associated with 1/34
 - H05H 2001/3421 transferred arc mode
 - H05H 2001/3426 pilot arc
 - H05H 2001/3431 coaxial cylindrical electrodes
 - H05H 2001/3436 hollow cathode with internal coolant flow
 - H05H 2001/3442 cathode with inserted tip
 - H05H 2001/3447 rod-like cathode
 - H05H 2001/3452 supplementary electrodes between cathode and anode, e.g. cascade
 - H05H 2001/3457 nozzle protection devices
 - H05H 2001/3463 oblique nozzle
 - H05H 2001/3468 vortex generator

H05H 2001/3473	safety means
H05H 2001/3478	geometrical details
H05H 2001/3484	convergent/divergent nozzle
H05H 2001/3489	contact starting
H05H 2001/3494	discharge parameter control
H05H 2001/46	..	using applied electromagnetic fields, e.g. high frequency or microwave energy (H05H 1/26 takes precedence)
H05H 2001/4607	...	Microwave discharges
H05H 2001/4615	Surface waves
H05H 2001/4622	Waveguides
H05H 2001/463	Antennas or applicators
H05H 2001/4637	Cables
H05H 2001/4645	...	Radiofrequency discharges
H05H 2001/4652	Inductively coupled
H05H 2001/466	Electrodes
H05H 2001/4667	Coiled antennas
H05H 2001/4675	Capacitively coupled
H05H 2001/4682	Associated power generators, e. G. Circuits, matching networks
H05H 2001/469	...	Flow through, i.e the plasma fluid flowing in a non-dielectric vessel
H05H 2001/4692	dielectric barrier discharge (H05H 1/2406 takes precedence)
H05H 2001/4695	Arc discharge
H05H 2001/4697	Glow discharge
H05H 2001/48	..	using an arc (H05H 1/26 takes precedence)
H05H 2001/481	...	Corona discharges
H05H 2001/483	Pointed electrodes
H05H 2001/485	Cylindrical electrodes, e.g. Rotary drums electrodes
H05H 2001/486	Filamentary electrodes
H05H 2001/488	Segmented electrodes
H05H 2006/00		Targets for producing nuclear reactions (supports for targets or objects to be irradiated G21K 5/08){preparation of tritium C01B 4/00 }; {targets, e.g. pellets for fusion reactions by laser or charged particles beam injection H05H 1/22 }
H05H 2006/002	.	Windows
H05H 2006/007	.	Radiation protection arrangements , e.g. screens
H05H 2007/00		Details of devices of the types covered by groups H05H 9/00, H05H 11/00, H05H 13/00
H05H 2007/001	.	{ Arrangements for beam delivery or irradiation (irradiation systems per se G21K 5/00); }
H05H 2007/002	..	for modifying beam trajectory , e.g. gantries
H05H 2007/004	..	for modifying beam energy, e.g. spread out Bragg peak devices

- H05H 2007/005 .. for modifying beam emittance , e.g. stochastic cooling devices, stripper foils
- H05H 2007/007 .. for focusing the beam to irradiation target
- H05H 2007/008 .. for measuring beam parameters

- H05H 2007/02 . Circuits or systems for supplying or feeding radio-frequency energy ([radio-frequency generators H03B](#))
- H05H 2007/022 .. Pulsed systems
- H05H 2007/025 .. Radiofrequency systems
- H05H 2007/027 .. Microwave systems

- H05H 2007/04 . Magnet systems {e.g. undulators, wigglers ([free-electron laser H01S 3/0903](#))}; Energisation thereof
- H05H 2007/041 .. for beam bunching , e.g. undulators
- H05H 2007/043 .. for beam focusing
- H05H 2007/045 .. for beam bending
- H05H 2007/046 .. for beam deflection
- H05H 2007/048 .. for modifying beam trajectory , e.g. gantry systems

- H05H 2007/06 . Two-beam arrangements; Multi-beam arrangements ([storage rings](#)); Electron rings
- H05H 2007/065 .. Multi-beam merging , e.g. funneling

- H05H 2007/08 . Arrangements for injecting particles into orbits
- H05H 2007/081 .. Sources
- H05H 2007/082 ... Ion sources, e.g. ECR, duoplasmatron, PIG, laser sources
- H05H 2007/084 ... Electron sources
- H05H 2007/085 .. by electrostatic means
- H05H 2007/087 .. by magnetic means
- H05H 2007/088 .. by mechanical means, e.g. stripping foils

- H05H 2007/12 . Arrangements for varying final energy of beam
- H05H 2007/122 .. by electromagnetic means , e.g. RF cavities
- H05H 2007/125 .. by mechanical means , e.g. stripping foils
- H05H 2007/127 .. by emittance variation , e.g. stochastic cooling

- H05H 2007/22 . Details of linear accelerators, e.g. drift tubes ([H05H 7/02 to H05H 7/20 take precedence](#))
- H05H 2007/222 .. drift tubes
- H05H 2007/225 .. coupled cavities arrangements
- H05H 2007/227 .. power coupling , e.g. coupling loops

- H05H 2240/00 Test**

- H05H 2240/10 . at atmospheric pressure

H05H 2240/20 . Non-thermal plasma

H05H 2242/00 Auxiliary systems

H05H 2242/10 . Cooling arrangements

H05H 2242/1005 .. Power supply other than for plasma torches

H05H 2245/00 test

H05H 2245/104 . spiral electrodes

H05H 2245/12 . Applications

H05H 2245/121 .. treatment of exhaust gas, e.g. Ambient air, ozonizers

H05H 2245/1215 ... Exhaust gas

H05H 2245/122 .. medical applications { e.g. plasma scalpels, blades, bistouri}

H05H 2245/1225 ... Sterilization of objects

H05H 2245/123 .. surface treatments

H05H 2245/1235 ... coating of large volume items

H05H 2245/124 .. production of nanostructures

H05H 2245/125 .. portable devices

H05H 2277/00 Applications

H05H 2277/10 . Medical devices

H05H 2277/11 .. Radiotherapy

H05H 2277/113 ... Diagnostic systems

H05H 2277/116 ... Isotope production

H05H 2277/12 . Ion implantation

H05H 2277/13 . High energy applications , e.g. fusion

H05H 2277/14 . Portable devices

H05H 2277/1405 .. Detection systems